



IFW  
Attorney Docket No.:  
SP02-260

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: BELLMAN, ET AL

Serial No: 10/722,769

Filing Date: November 26, 2003

Title: METHOD USING MULTI-  
COMPONENT COLLOIDAL  
ABRASIVES FOR CMP  
PROCESSING OF  
SEMICONDUCTOR AND  
OPTICAL MATERIALS

Group Art Unit: 1765

Examiner: CHEN, Kin Chan

**RESPONSE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO THE EXAMINER'S RESTRICTION REQUIREMENT**

In response to the Office Action dated November 4, 2004 in the above-captioned application, please enter the following Amendments and Remarks.

No amendment to the specification is being made in this paper.

No amendment to the claims is being made in this paper.

Remarks begin on page 2 in this paper.